



Cor Claeys

Cor Claeys received the electrical-mechanical engineering degree in 1974 and the Ph.D. degree in 1979, both from the Katholieke Universiteit Leuven (KU Leuven), Belgium. Since 1990 he is a Professor at the KU Leuven. In 1984, he joined IMEC as Head of Silicon Processing Group. From 1990 he was Head of the research group on Radiation Effects, Cryogenic Electronics and Noise Studies. Recently, he became as Director Advanced Semiconductor Technologies responsible for Strategic Relations. He authored and co-authored eight book chapters and more than 800 technical papers and conference contributions. Prof. Claeys is a Fellow of IEEE and of the Electrochemical Society. Since 2000 he is an IEEE Electron Devices Society Distinguished Lecture and presently EDS President He also received the IEEE Third Millennium Medal. He was the Chair of the Electronics Division (2001-2003) of the Electrochemical Society. In 2004 he received the Electronics Division Award of the Electrochemical Society.